

00684.002980.1

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	) Previous Examiner: P. Connolly
	:
Osamu KAKUCHI et al.	) Previous Group Art Unit: 2877
	:
Application No.: Divisional of Application	)
No. 09/533,376, filed March 22, 2000	:
	)
Filed: July 17, 2003	:
	) July 17, 2003
For: EXPOSURE APPARATUS WITH	:
INTERFEROMETER	)

**Mail Stop Patent Application**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT AND  
LETTER SUBMITTING SUBSTITUTE SPECIFICATION

Sir:

Prior to examination on the merits, please amend the above-identified application as follows:

INTRODUCTORY COMMENTS

This Amendment has been prepared in accordance with the Revised Format established by the U.S. Patent and Trademark Office, as permitted in the Pre-OG Notice dated February 4, 2003, and entitled "Amendments in a Revised Format Now Permitted."